



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 5415

SERIAL NUMBER 10/506,806	FILING DATE 09/07/2004  RULE	CLASS 257	GROUP ART UNIT 2811	ATTORNEY DOCKET NO. 018765-177
-----------------------------	---------------------------------------	--------------	------------------------	--------------------------------------

## APPLICANTS

Yoshihisa Saimoto, Nagoya-shi Aichi, JAPAN;

Makoto Kataoka, Sodegaura-shi Chiba, JAPAN;

Masafumi Miyakawa, Nagoya-shi Aichi, JAPAN; Shinichi Hayakawa, Nagoya-shi Aichi, JAPAN;

Kouji Igarashi, Nagoya-shi Aichi, JAPAN;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP03/03705 03/26/2003

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-090493 03/28/2002

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	JAPAN		4	2
Examiner's Signature	Initials			

## ADDRESS

21839

BURNS DOANE SWECKER &amp; MATHIS L L P

POST OFFICE BOX 1404

ALEXANDRIA, VA

22313-1404

## TITLE

Pressure sensitive adhesive film for protection of semiconductor wafer surface and method of protecting semiconductor wafer with the pressure sensitive adhesive film

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
------------	---	---